

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Hiroyuki ARAKI et al.

Serial No.: 10/730,465

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For: SUBSTRATE TREATING APPARATUS AND SUBSTRATE TREATING METHOD

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VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

Responsive to the Office Action dated December 1, 2006, the applicants elect invention I, claims 1-8, substrate treating apparatus.

Applicants further elect the species of claim 2.

THIS CORRESPONDENCE IS BEING
SUBMITTED ELECTRONICALLY
THROUGH THE PATENT AND
TRADEMARK OFFICE EFS FILING
SYSTEM ON December 21, 2006.

Respectfully submitted,



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